High-Vacuum System for Laser Deposition



UHV vacuum chamber: Dia.12", with 18 ports, blank flanges, bolts/nuts, gaskets **UHV** gate valve:

8", pneumo, with position indicator, roughing port, bolts/nuts, gaskets

8" 560l/s with vent valve and power supply

Oil-free mechanical pump: 35m³/h

valves pneumo, with position indicator

Vacuum controller: with 1 Penning gauge, 2 Pirani gauges, cables, and 2 spare gauges **Quartz crystal monitor:** with one shuttered sensor, UHV feed through, sensors kit

Pumping controller

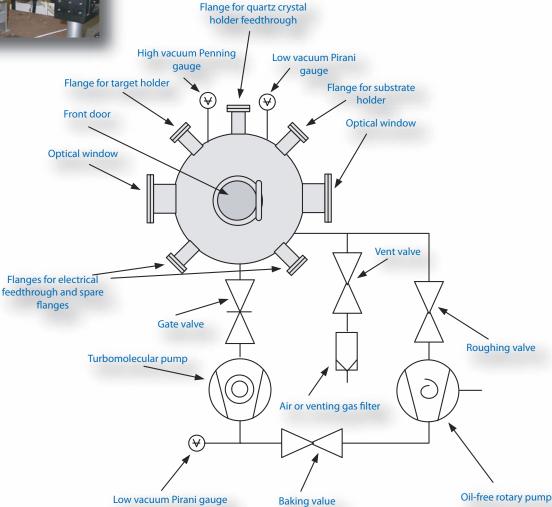
Turbomolecular pump:

UHV quick access door 8" with view port

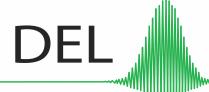
UHV silica view ports 6" (uncoated)

Moveable (rotating, tilting) target and substrate holders

General controller (water, compressed air, power distribution, etc.)



- 1. Vacuum chamber made of polished stainless steel
- 2. All components are UHV and can be baked to 200 °C
- 3. Expected ultimate vacuum 10^{-7} 10^{-8} torr



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